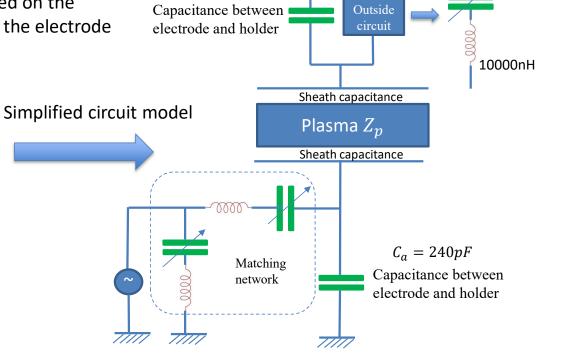
Experiment setup

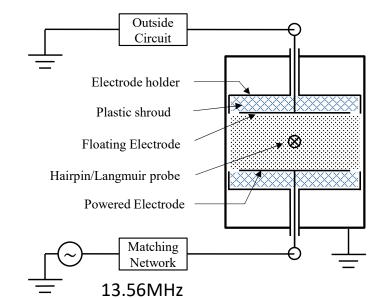


12~500pF

- Electron density n_e is measured by hairpin probe
- Plasma potential V_p and T_e are taken by Langmuir probe
- A V/I probe is connected to the bottom electrode, measuring root mean square RF voltage V_{rms}
- A retarding field energy analyzer (RFEA) is mounted on the bottom electrode, which gives the DC self-bias of the electrode and ion velocity distribution functions (IVDFs).

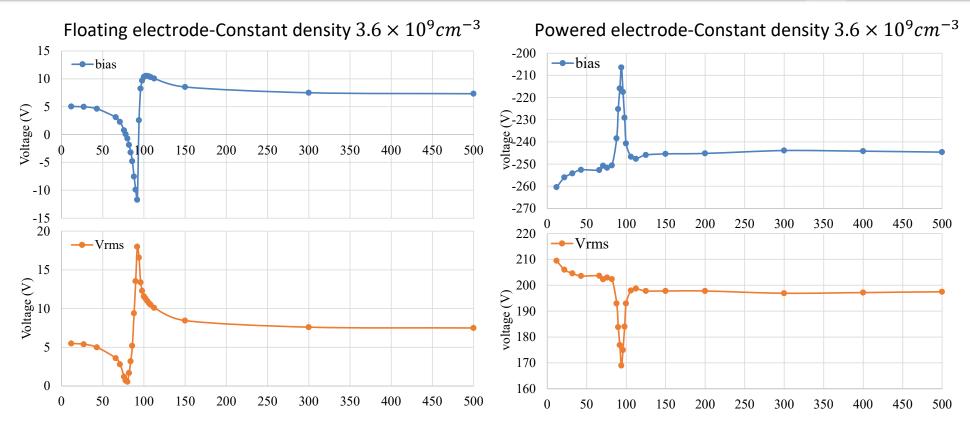


 $C_b = 240 pF$



Analysis of constant density cases – 20mTorr Argon





- DC self-bias of powered electrode can be increased by 20%
- DC self-bias of floating electrode can be decreased by 200% (from 10V to -10V)
- Sheath of floating electrode shares more delivered power at resonance.